# **Refractive Index Evaluation of Synthetic Silica Glass** by the Ultrasonic Microspectroscopy Technology

超音波マイクロスペクトロスコピー技術による合成石英 ガラスの屈折率評価

Mototaka Arakawa<sup>1†</sup>, Yuji Ohashi<sup>1</sup>, Yuko Maruyama<sup>1</sup>, Jun-ichi Kushibiki<sup>1</sup>, Kenji Moriyama<sup>2</sup>, Hideharu Horikoshi<sup>2</sup> (<sup>1</sup>Grad. School of Eng., Tohoku Univ.; <sup>2</sup>Tosoh SGM Co.) 荒川 元孝<sup>1†</sup>, 大橋 雄二<sup>1</sup>, 丸山 由子<sup>1</sup>, 櫛引 淳一<sup>1</sup>, 森山 賢二<sup>2</sup>, 堀越 秀春<sup>2</sup> (<sup>1</sup>東北大 院工,<sup>2</sup>東ソー・エスジーエム)

## 1. Introduction

Synthetic silica (SiO<sub>2</sub>) glass is widely used as optical components because of its high purity, high optical trasnsmittance, and high homogenetiy of refractive index. SiO<sub>2</sub> glass with the optical transmittance for wavelength at 193 nm higher than 99.8%, the distributions of refractive index normal and parallel to the optical axis less than  $1 \times 10^{-6}$  and  $5 \times 10^{-6}$ , respectively, and the birefrigence lower than 2 nm/cm, has been developed for lens of the production systems of semiconductor devices (stepper)<sup>1)</sup>. It is necessary to improve the homogeneity of refractive index of SiO<sub>2</sub> glass for lens of stepper, in order to reduce the size of semiconductor integrated circuits. Refractive indicies of SiO<sub>2</sub> glass depend not only to concentrations of impurities such as OH and chroline, but also to fictive temperature  $(T_{\rm F})^{2}$ . We developed a method of evaluating  $T_{\rm F}$  for SiO<sub>2</sub> glass by acoustic properities measurements using ultrasonic micro-spectroscopy (UMS) technology<sup>3)</sup>. The resolution of  $T_{\rm F}$  by longitudinal velocity measuments is  $\pm 0.3 \pm 0.4$ °C, and it is by one or two orders of magnitude greater than that measured by the conventional methods $^{4,5)}$ . In this paper, relationships among refractive index and acoustic properties for SiO<sub>2</sub> glass were obtained to establish an indirect ultrasonic method for evaluating refractive index disributions of SiO<sub>2</sub> glass ingots.

# 2. Specimens

Specimens were prepared from five synthetic silica glass ingots by the direct method (ES; Tosoh SGM Co.). OH concentrations of the ingots measured by infrared spectroscopy<sup>6)</sup> were 1040-1290 wtppm. In order to obtain  $T_{\rm F}$  dependence of refractive index, the ingots were

heat-treated at the different annealing temperatures. Striae distributions were observed for the cubic blocks with sizes of 70 mm  $\times$  70 mm  $\times$  70 mm cut from the central parts of the ingots, and prisms for refractive index measurements were prepared from the homogeneous parts of each block. No striae were observed for three blocks and weak striae were observed for two blocks. Specimens for acoustic properties measurements were obtained from the neighborhood of the cubic blocks.

In order to obtain  $T_{\rm F}$  dependence of acoustic properties, several specimens were also prepared from an ingot, and heat-treated at the different annealing temperature from 850°C to 1150°C.

### 3. Experiments and discussion

Refractive indices (n) at 632.82 nm were measured by the minimum deviation method using a spectrometer. Longitudinal velocities  $(V_1)$  were measured by the plane-wave ultrasonic material characterization system<sup>7)</sup>. Densities  $(\rho)$  were measured by the Archimedes method<sup>8)</sup>. Measurement accuracies for *n*,  $V_1$  and  $\rho$  are  $\pm 1$  ppm  $(\pm 1.46 \times 10^{-6} \text{ for SiO}_2 \text{ glass}), \pm 0.05 \text{ m/s}, \text{ and } \pm 0.05$  $kg/m^3$ , respectively. Relationships among refractive indices, longitudinal velocities, and densities are presented in Fig. 1. The following relationships among  $V_1$  [m/s],  $\rho$  [kg/m<sup>3</sup>], and *n* were obtained.

$$V_1 = -3.54 \times 10^5 \times n + 521608.9 \tag{1}$$

$$\rho = -7.72 \times 10^3 \times n + 13446.1 \tag{2}$$

 $V_1$  and  $\rho$  become smaller, as *n* higher.

 $V_1$  and  $\rho$  were measured for the specimens to obtain  $T_F$  dependences of acoustic properties. Annealing temperature  $(T_A)$  dependences of  $V_1$  and  $\rho$  are shown in **Fig. 2**. The following relationships among  $V_1$ ,  $\rho$ , and  $T_F$  [°C] were obtained.

arakawa@ecei.tohoku.ac.jp



Fig. 1. Relationships among longitudinal velocities, densities, and refractive indices for  $SiO_2$  glass specimens.



Fig. 2. Annealing temperature  $(T_A)$  dependences of longitudinal velocity and density of SiO<sub>2</sub> glass.

Table 1. Sensitivities and resolutions for refractive index of  $SiO_2$  glass (ES) determined by acoustic properties measurements.

	Sensitivity	Resolution
$V_1$	$-2.8 \times 10^{-6}/(m/s)$	$1.4 \times 10^{-7}$
$\rho$	$-1.3 \times 10^{-4}/(\text{kg/m}^3)$	6.5×10 <sup>-6</sup>

$V_1 = 0.1565$	$\times$ <i>T</i> <sub>F</sub> + 5782.81	(3)
0.0051	T 105 00	(1)

$$\rho = 0.0051 \times T_{\rm F} + 2195.33 \tag{4}$$

From eq. (1)-(4), we can understand *n* becomes smaller as  $T_F$  higher. From eq. (3),  $T_F$  of the SiO<sub>2</sub> ingots were estimated from 877°C to 934°C.

**Table 1** presents sensitivities and resolutions of refractive indices determined by measuring acoustic properties. Resolution for refractive index of SiO<sub>2</sub> glass determined by longitudinal velocity is  $1.4 \times 10^{-7}$ , and it is by one order of magnitude higher than that measured by the minimum deviation method.

In Fig. 1, measured values (n = 1.457059) are deviated from the approximated lines. It might be caused by optical imhomogeneity of the prism.

#### 4. Summary

In this paper, relationships among refractive indices and acoustic properties were discussed. UMS technology is very useful for evaluating refractive index distributions of SiO<sub>2</sub> glass ingot, and it will be extremely useful for improving the homogeneity of SiO<sub>2</sub> glass ingot. Hereafter, we will obtain more accurate calibration line by fabricating specimens with different  $T_{\rm F}$  from a homogeneous SiO<sub>2</sub> glass ingot.

#### Acknowledgment

The authors are very grateful to Mr. H. Shishido for measurements for refractive index. This work was partially supported by a Research Grant in Aid from JST, a Grant in Aid for the Global COE program, and a Research Grant-in-Aid for Scientific Research from JSPS.

#### References

- 1. A. Fujinoki, T. Ohshima, H. Nishimura, Y. Yanaginuma, Japan patent P2009-78968A.
- 2. R. Brückner: J. Non-Cryst Solids 5 (1970) 123.
- J. Kushibiki, M. Arakawa, Y. Ohashi, and Y. Maruyama: Appl. Phys. Express 4 (2011) 056601.
- A. Agarwal, K. M. Davis, and M. Tomozawa: J. Non-Cryst. Solids 185 (1995) 191.
- 5. A. E. Geissberger and F. L. Galeener: Phys. Rev. B 28 (1983) 3266.
- K. M. Davis, A. Agarwal, M. Tomozawa, and K. Hirao: J. Non-Cryst. Solids 203 (1996) 27.
- J. Kushibiki and M. Arakawa: J. Acoust. Soc. Am. 106 (2000) 564.
- H. A. Bowman, R. M. Schoonover, and M. W. Jones: " J. Res. Natl. Bur. Stand. 71C (1967) 179.